.03500.011946

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	Examiner: C. Dexter
Akira FUNAKOSHI et al.	)	Examiner. C. Dexter
	:	Group Art Unit: 3724
Application No.: 08/801,464	)	
Filed: February 18, 1997	:	
Thed. Peditary 16, 1997	;	
For: SUBSTRATE CUTTING METHOD AND	)	May 27, 2003
SUBSTRATE CUTTING APPARATUS	:	(Tuesday after a Federal Holiday)
COMMISSIONER FOR PATENTS		
P.O. Box 1450		
Alexandria, VA 22313-1450		Dro-
g'		DECEIVED
Sir:		RECEIVED MAY 3 0 2003
Transmitted herewith is an Amendment in the ab	ove-i	dentified applied that the
		CENTER R3700
X No additional fee is required.		•

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	4	MINUS	34	.0	x \$ 9 \$18	\$0.00
INDEP. CLAIMS	1	MINUS	6	0	x \$42 \$84	\$0.00
Fee for Mul	tiple Dependent claim	s \$135°/\$270	)			
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00	

	°Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed including the additional claims fees.
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 C.F.R. § 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. §§ 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
	A check in the amount of \$ to cover the Extension fee for response within additional months is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
	Attorney for Applicants Jack S. Cubert

Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
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AND SUBSTRATE CUTTING	:	May 27, 2003
APPARATUS	)	(Tuesday after a Federal Holiday)

The Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

Applicants are in receipt of an Office Action mailed February 26, 2003. A Request for Continuing Examinations is being filed concurrently. Prior to further examination on the merits, please amend the above-identified application as follows:

The present Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice entitled "Amendments in a Revised Format Now Permitted," a copy of which is attached.